

# **The Influence of Hydrogen-Argon Mixed Shielding Gases on Electro Spark Deposition**

An Audio/Visual and Temperature  
recorded Deposition process followed  
by Microstructural analysis with SEM  
and EDS.

# Electro-Spark Deposition

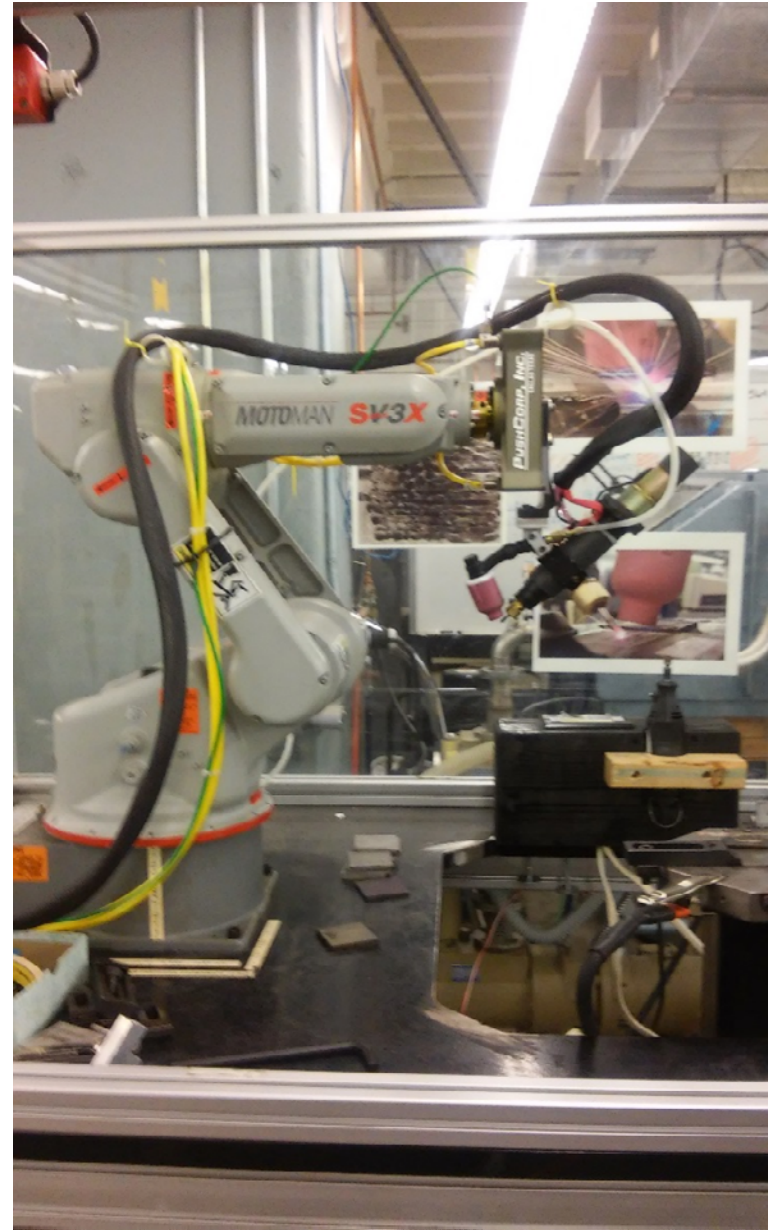
- Micro-Welding Additive Technology
- High Electrical Heat Input and Short Pulse Duration (50-75  $\mu\text{s}$ ) Via Capacitive Discharge
- High Cooling Rate
- Spark Hardening



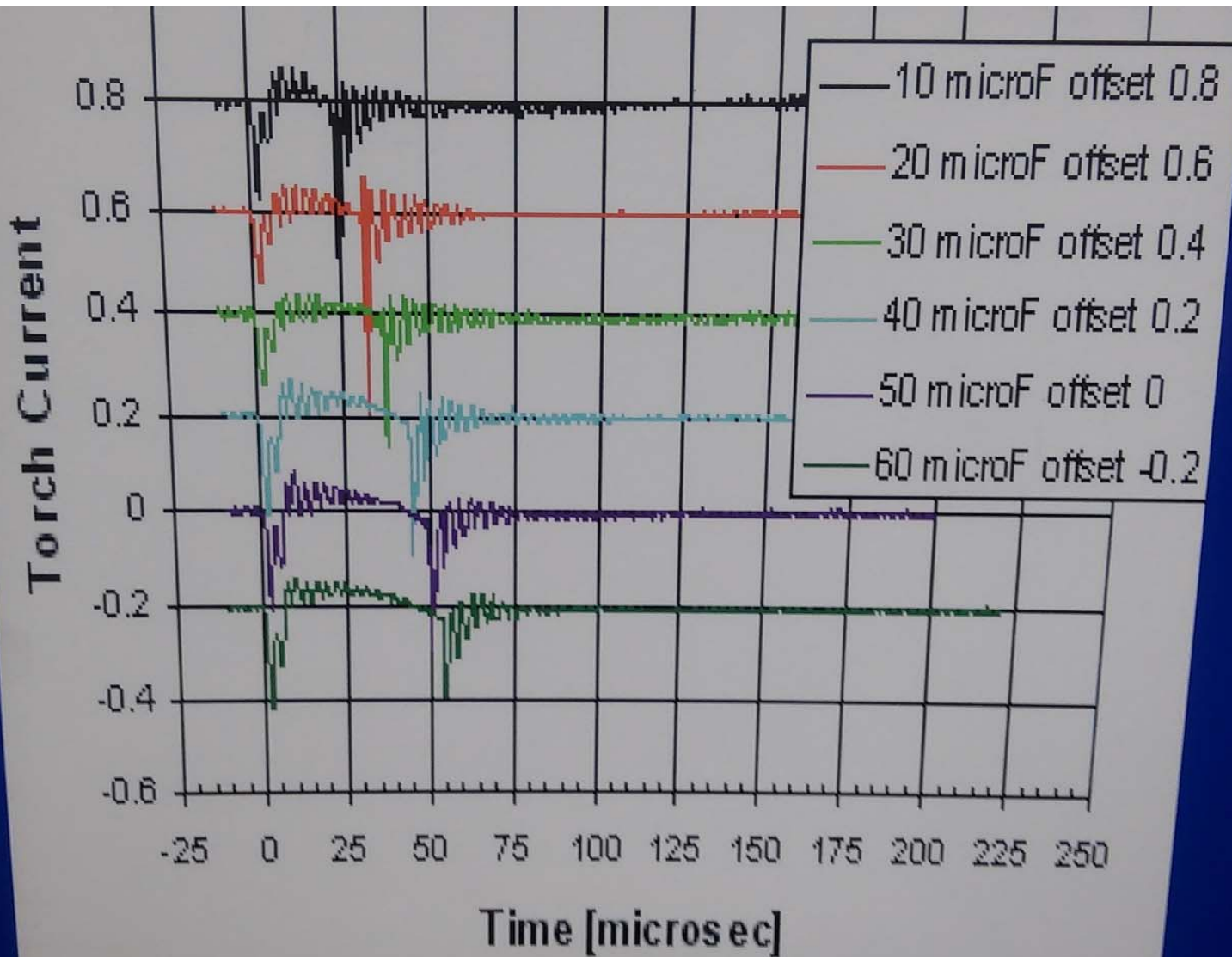
Power Source and Torch



Electrode and Shield Gas Cup



Robotic Arm with Mounted Torch



Electrical Current Behavior

# Project Scope

- 95% Ar, 5% H<sub>2</sub> shield gas with 316L and 304 stainless steel
- Metallographic and Scanning Electron Microanalysis with EDS
- Recording of the process live
  - Video Recording
  - Frequency Spectrum Recording
  - Temperature Recording

# Shielding Gases and their Influence on GMAW Welding

- Hydrogen-Argon
  - Hydrogen increases arc stability
  - Increases amount of material melted per discharge



# System Setup



- Video Results
  - Air Atmosphere



- 100% Ar Shield Gas



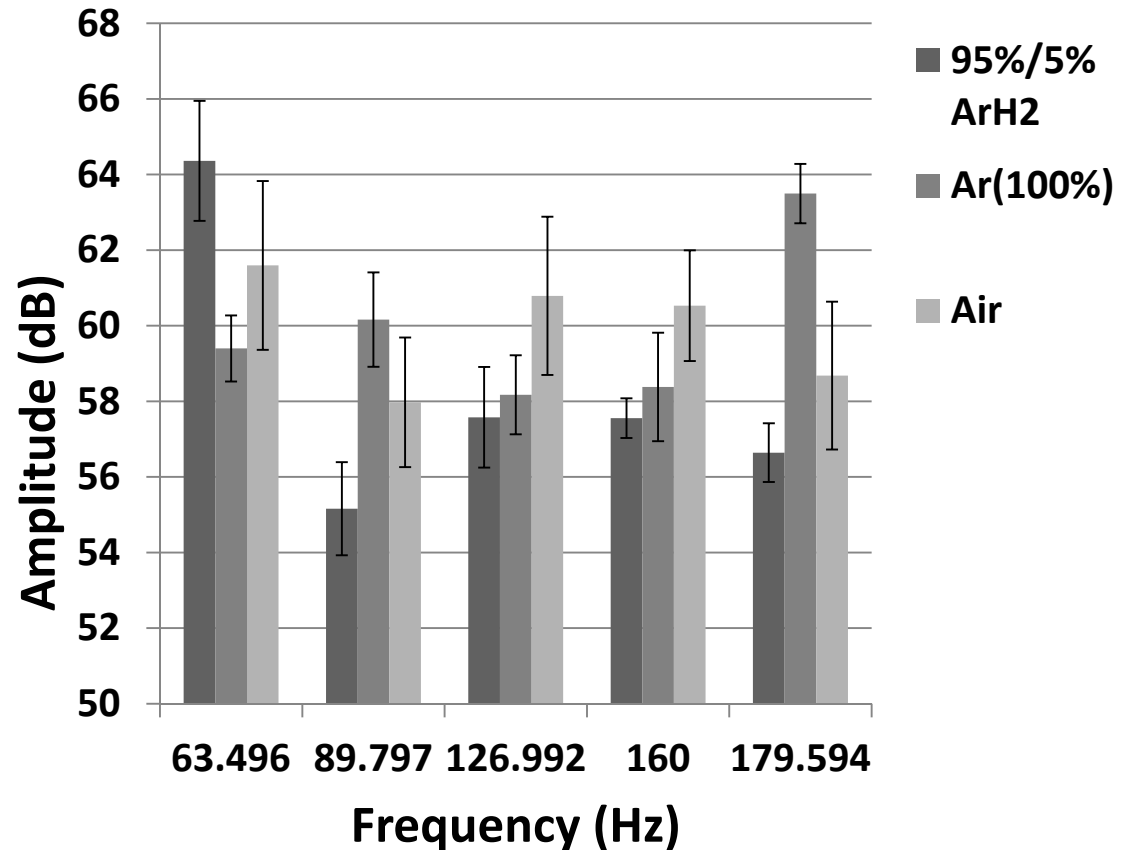
- Ar/H<sub>2</sub> Shield Gas





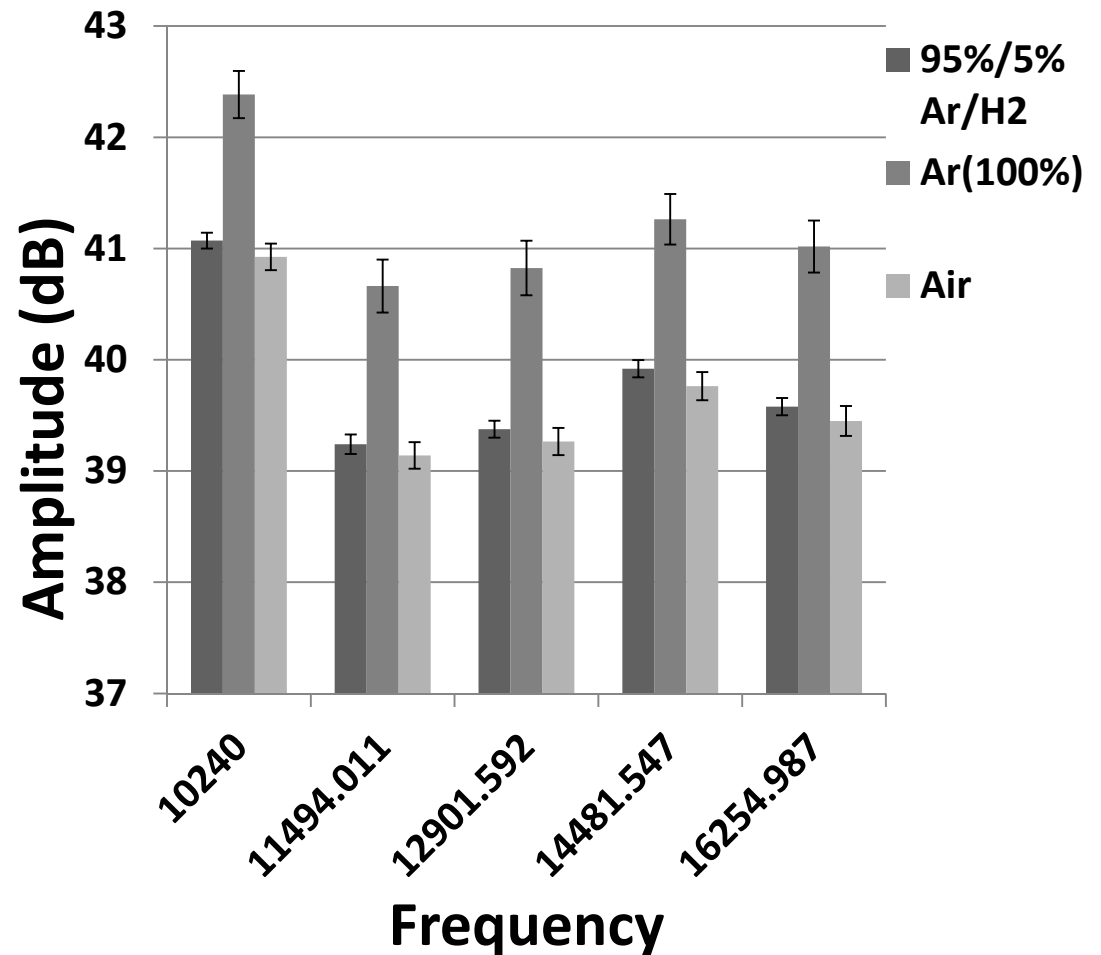
# Frequency Spectrum Results

- Frequencies with large amplitude difference tended to have higher variance
- Hard to verify changes due to noise



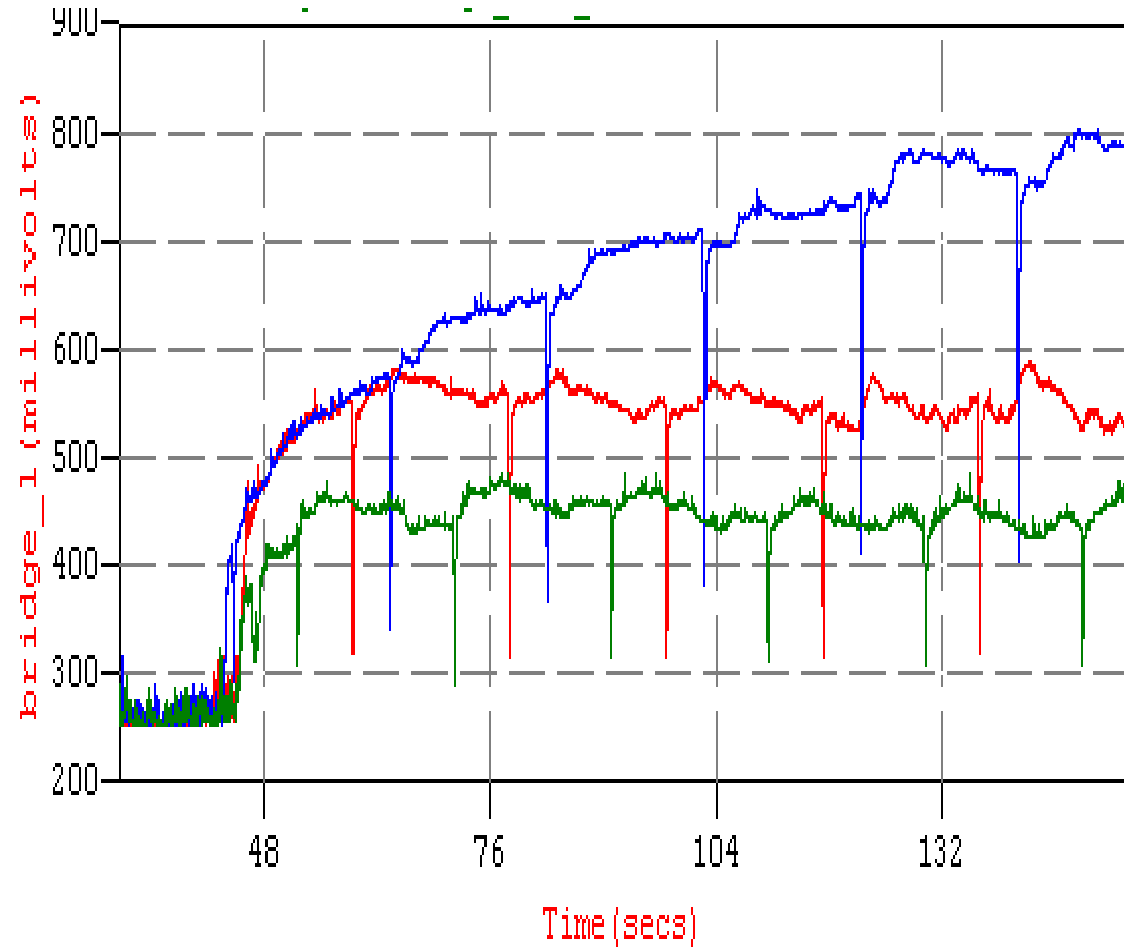
# Frequency Spectrum Results

- Frequencies with less variance showed more similarity in discharge sound between Air and Ar/H<sub>2</sub> than with Ar

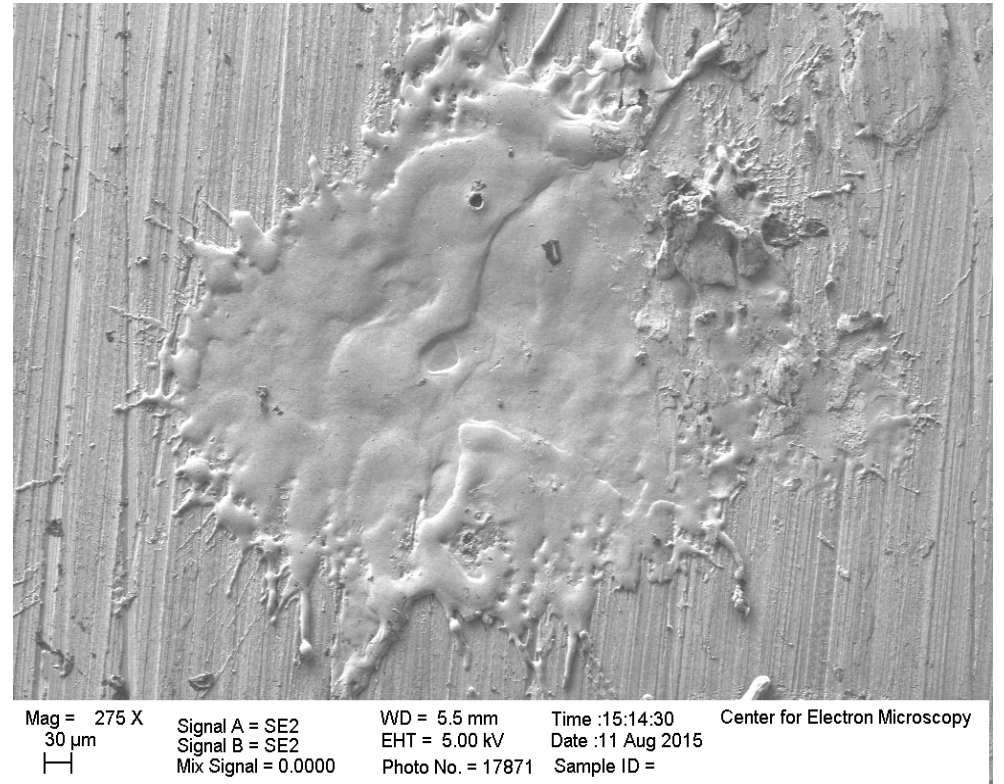
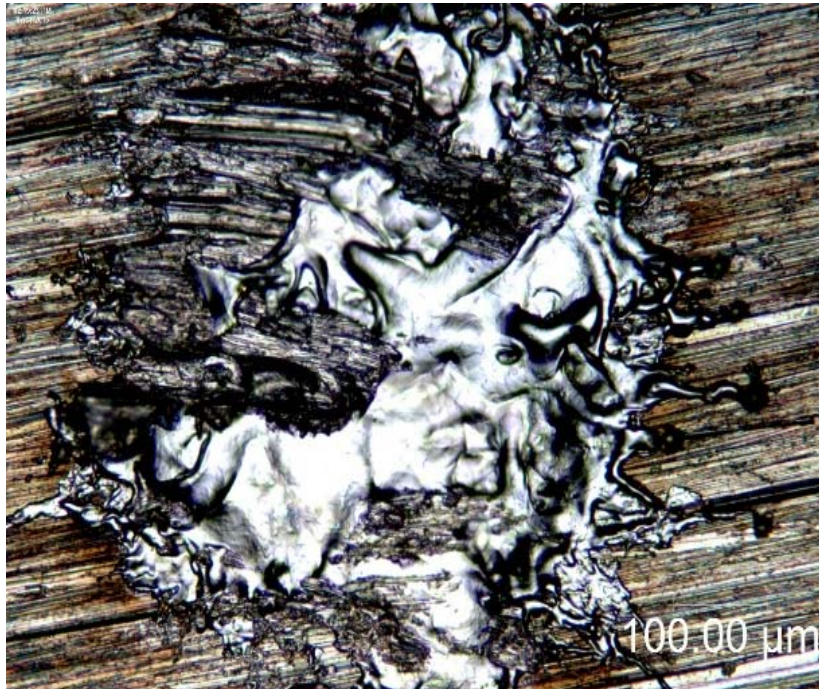


# Temperature Results

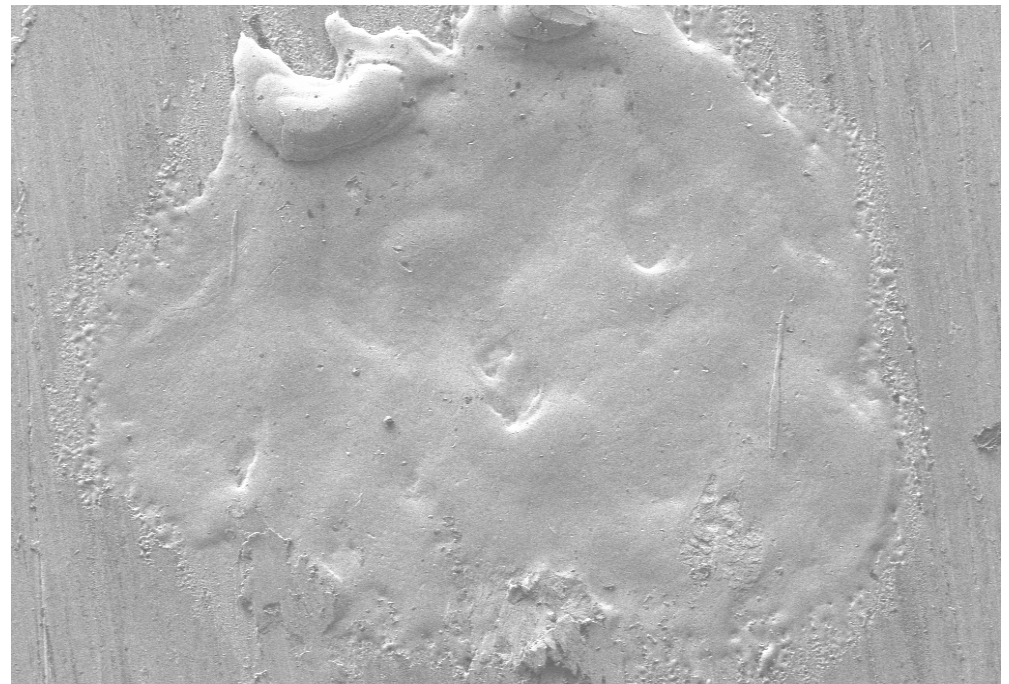
- Electrode Temperature mV signal
- **Blue: Air**
- **Red: Ar**
- **Green: Ar/H<sub>2</sub>**



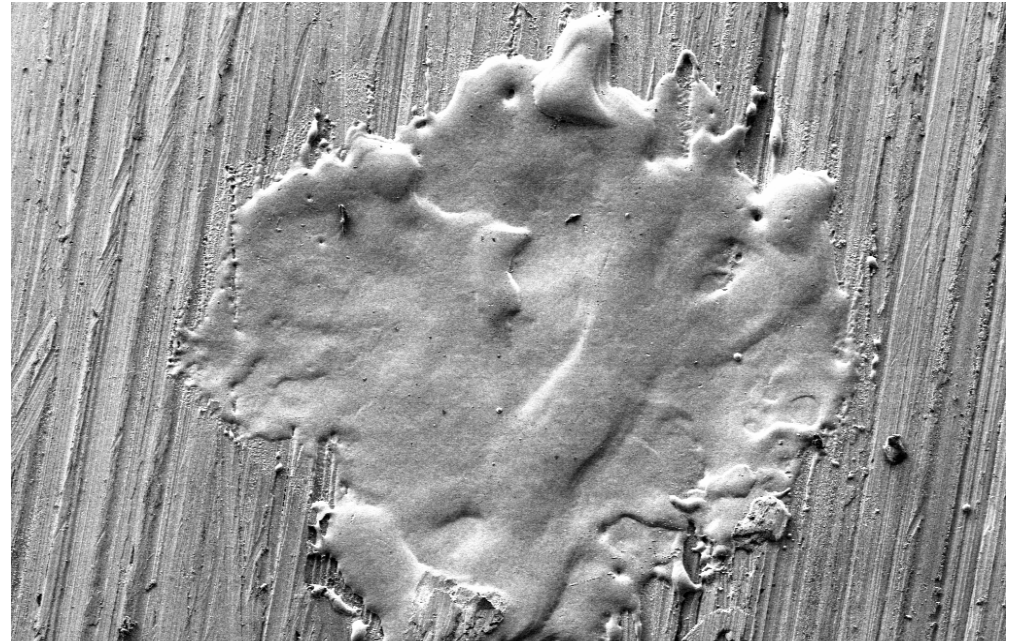
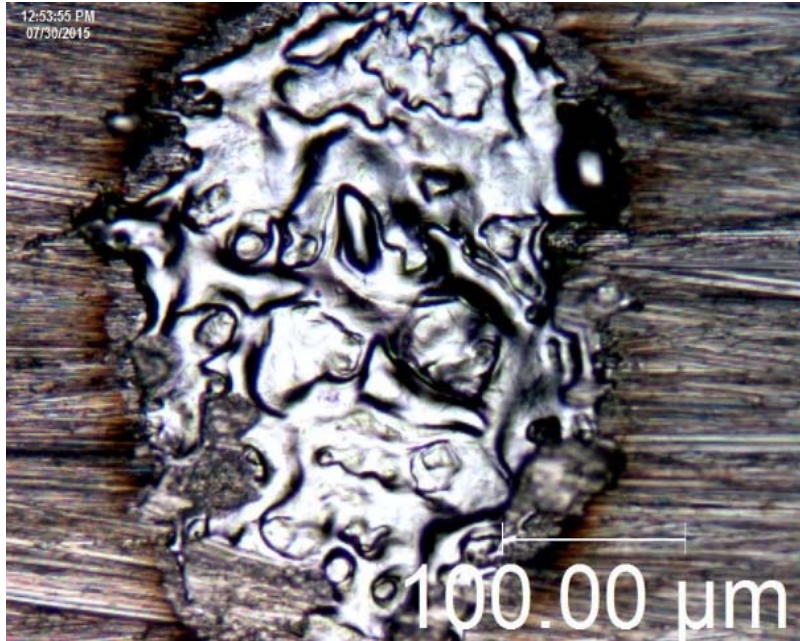
# Single Splat Images



Mag = 275 X      Signal A = SE2      WD = 5.5 mm      Time :15:14:30      Center for Electron Microscopy  
30 μm      Signal B = SE2      EHT = 5.00 kV      Date :11 Aug 2015  
H      Mix Signal = 0.0000      Photo No. = 17871      Sample ID =

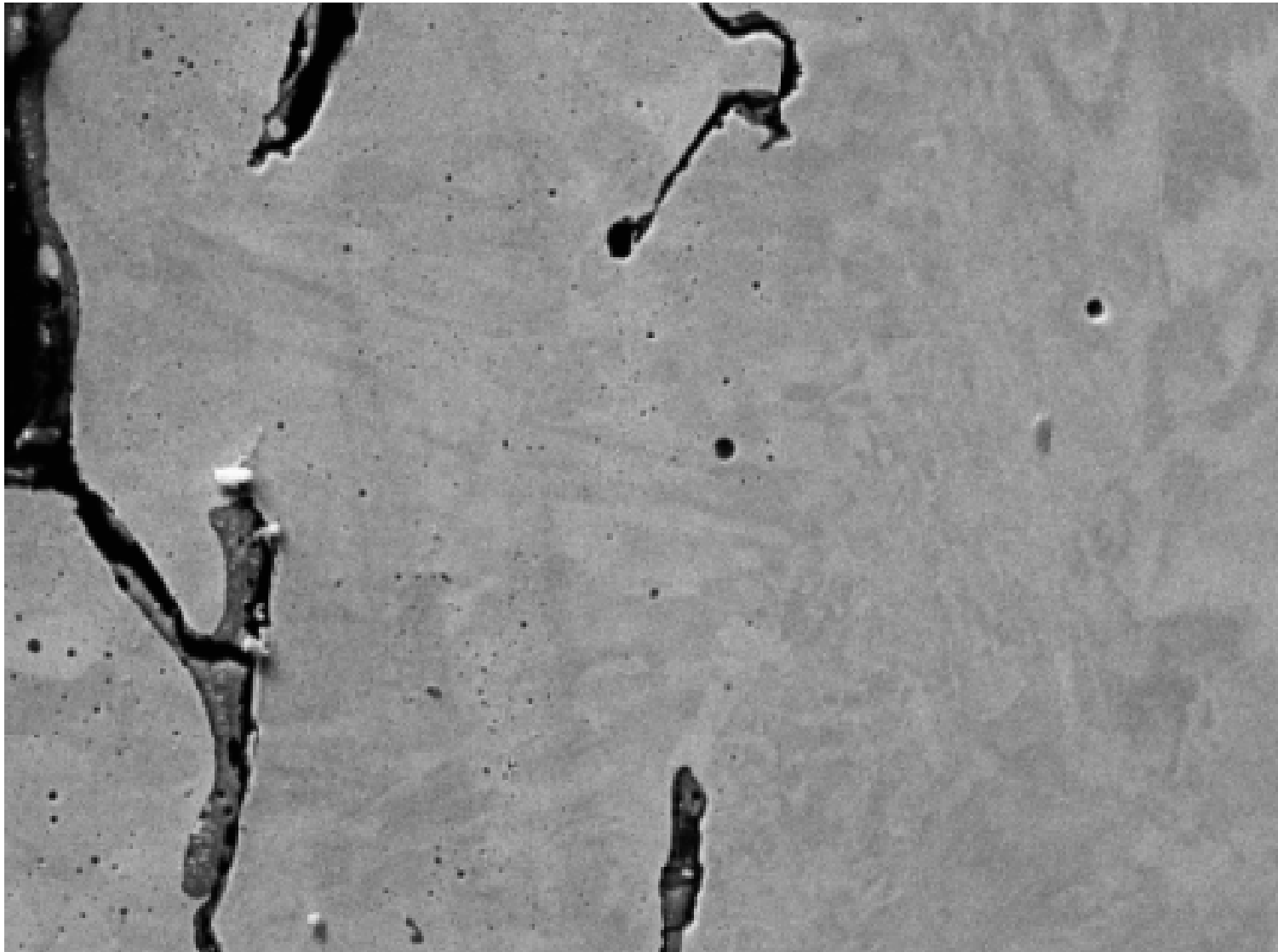


Mag = 401 X  
20 μm  
Signal A = SE2  
Signal B = SE2  
Mix Signal = 0.0000  
WD = 5.2 mm  
EHT = 5.00 kV  
Photo No. = 17872  
Time :15:24:32  
Date :11 Aug 2015  
Sample ID =  
Center for Electron Microscopy



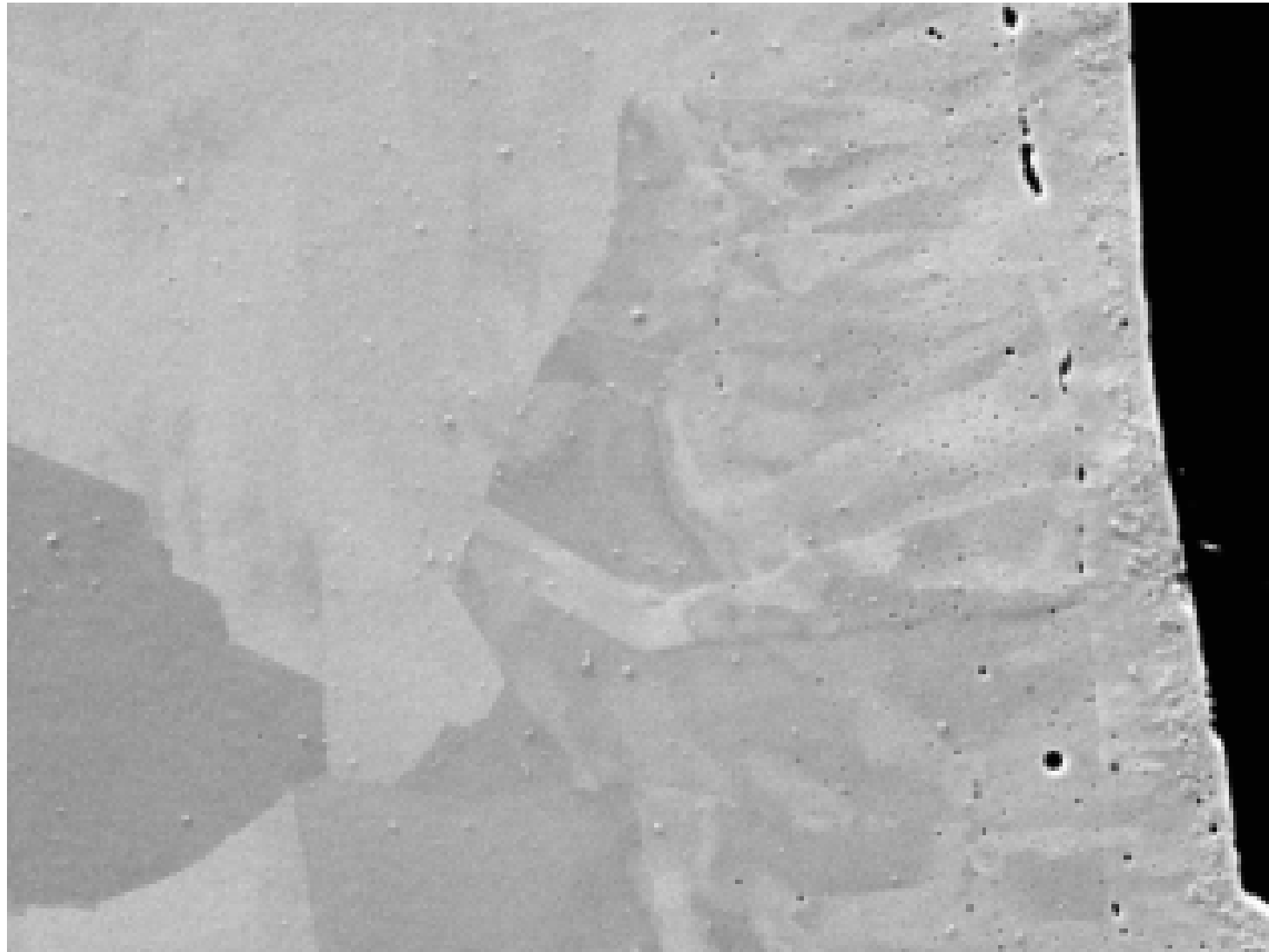
Mag = 307 X      Signal A = SE2      WD = 5.1 mm      Time :15:35:32      Center for Electron Microscopy  
30 μm      Signal B = SE2      EHT = 5.00 kV      Date :11 Aug 2015  
┌      Mix Signal = 0.0000      Photo No. = 17873      Sample ID =

# 316L Deposition in Air



25µm

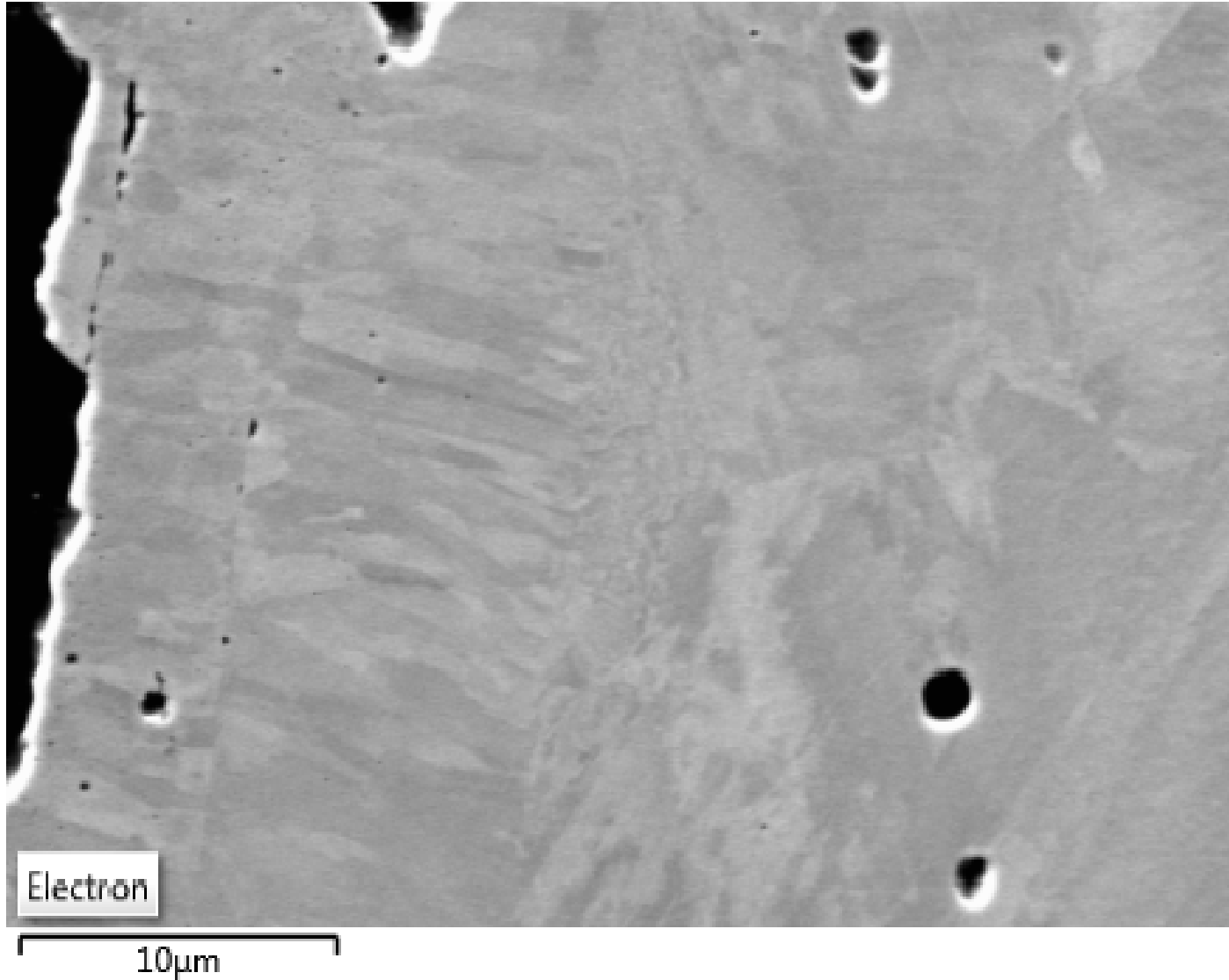
# 316L Deposition in Ar



25 $\mu$ m



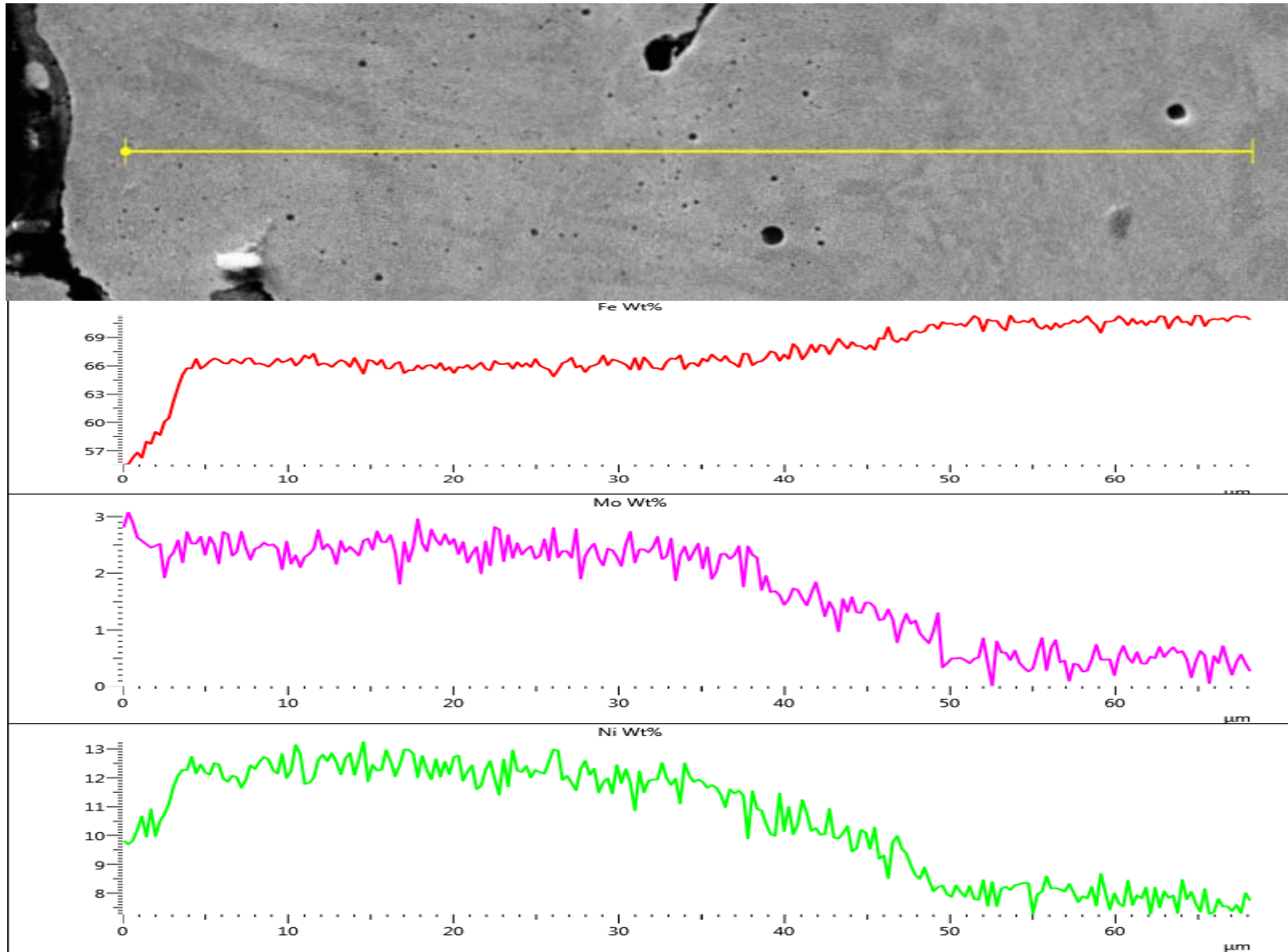
# 316L Deposition in Ar/H<sub>2</sub>



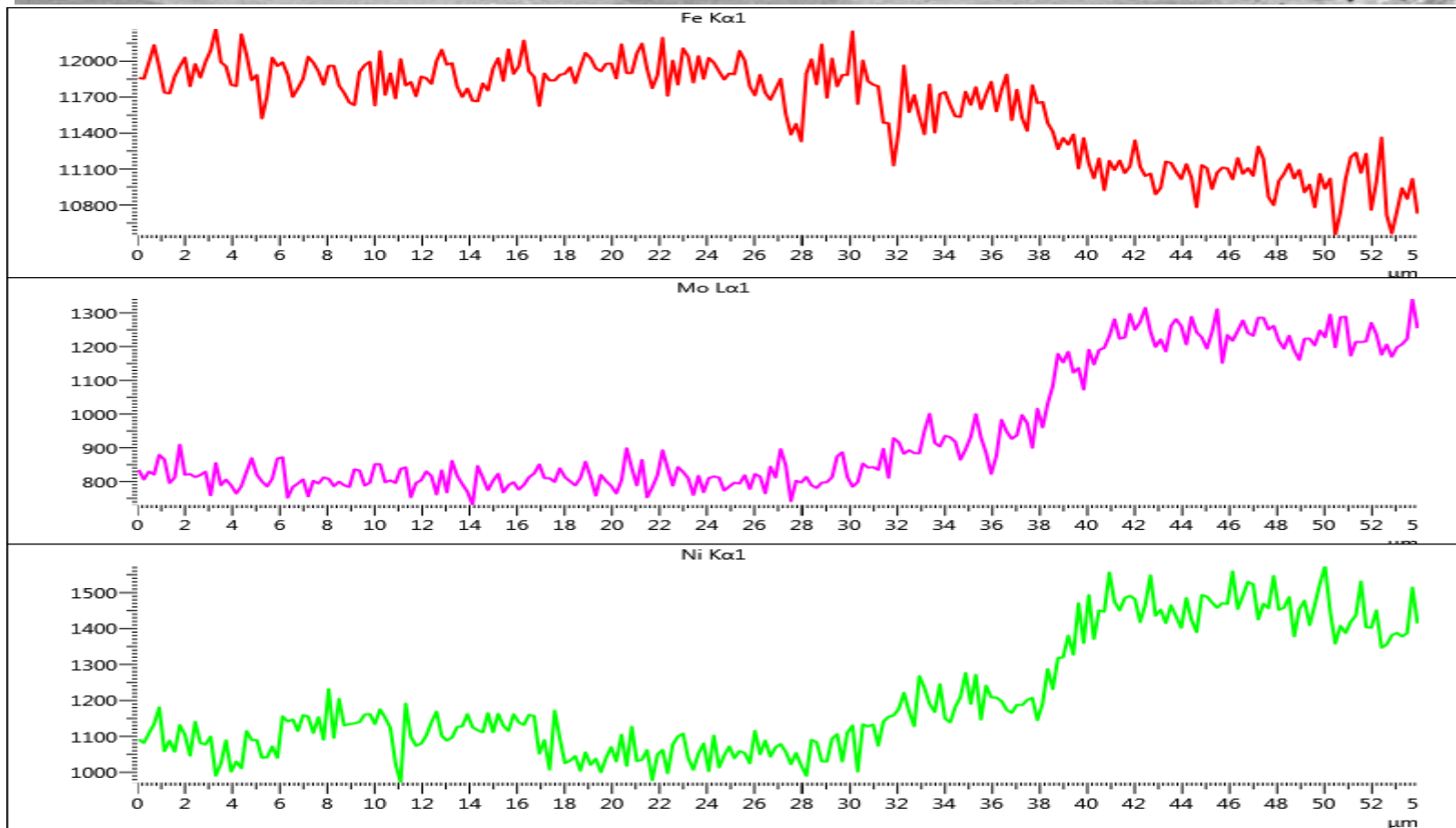
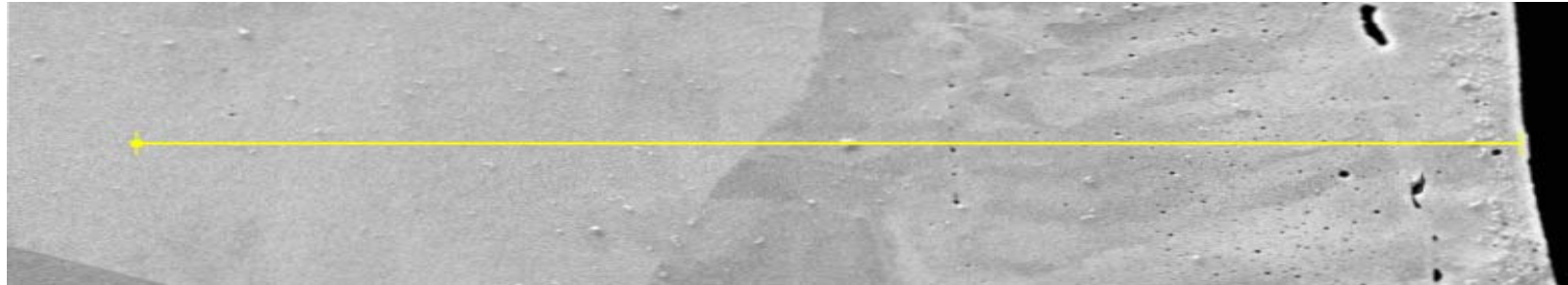
# Line Scans

- Red: Iron
- Pink: Molybdenum
- Green: Nickel

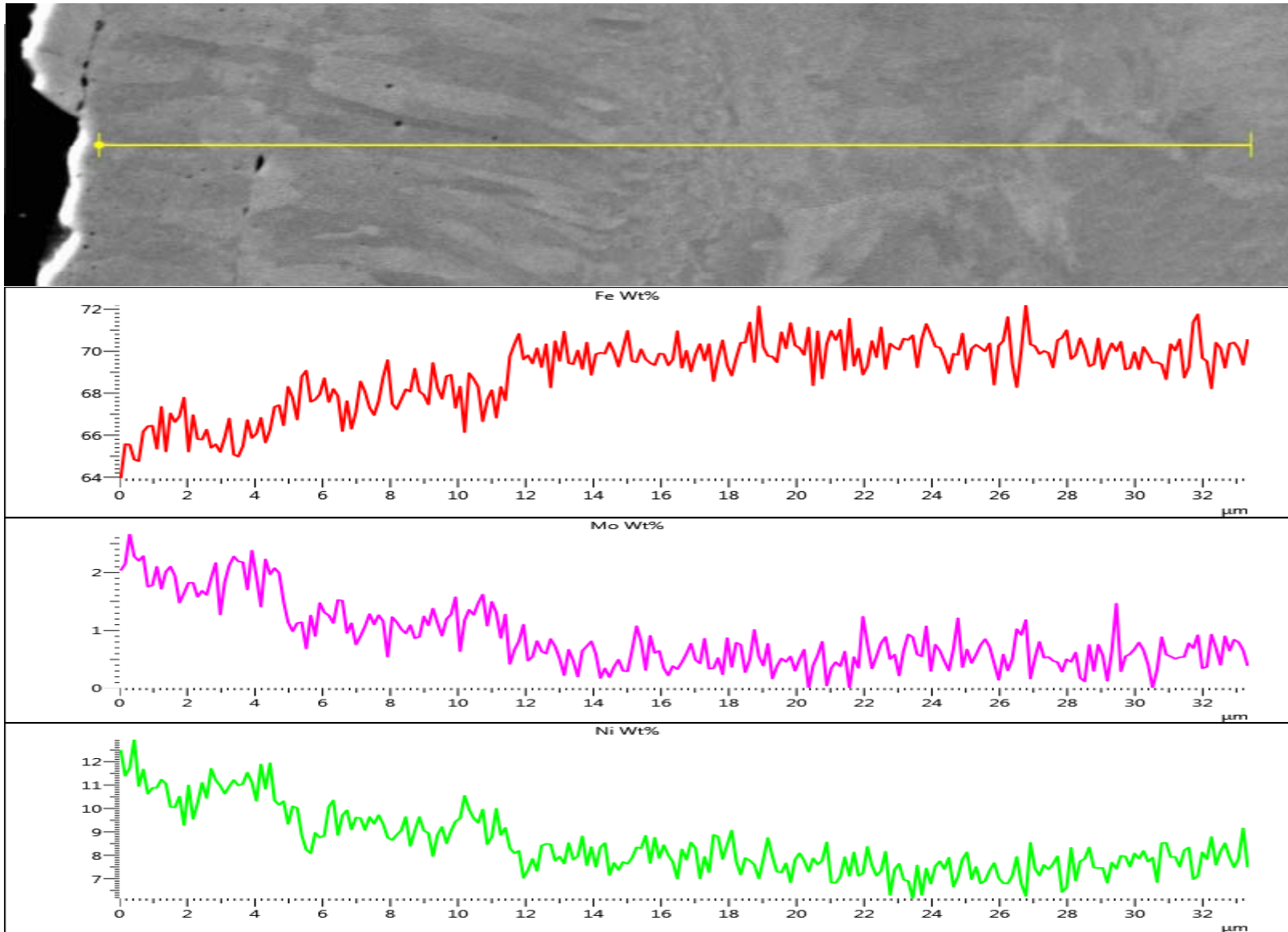
# Line Scans (Air)



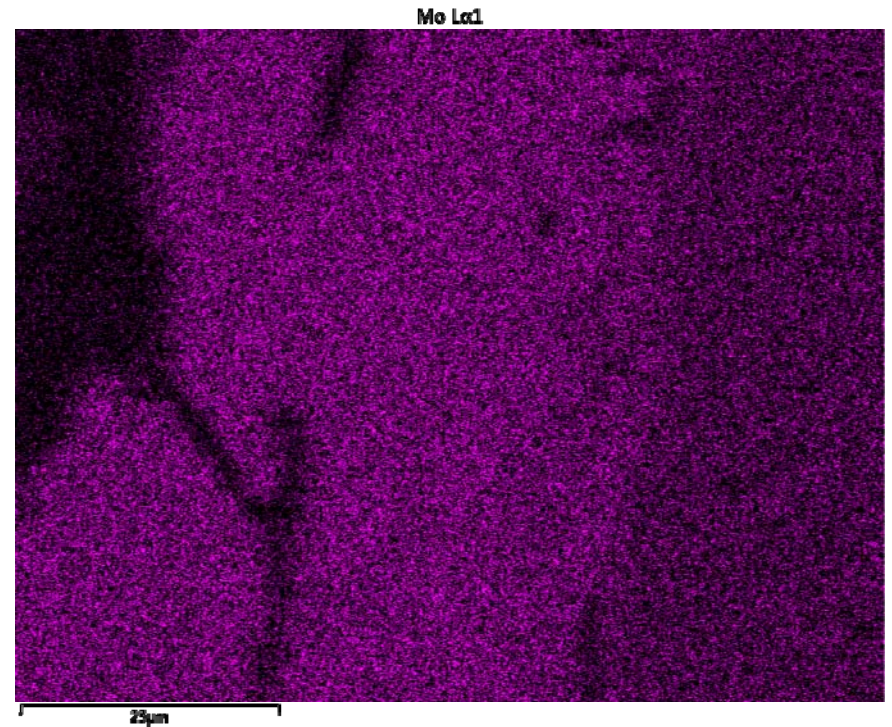
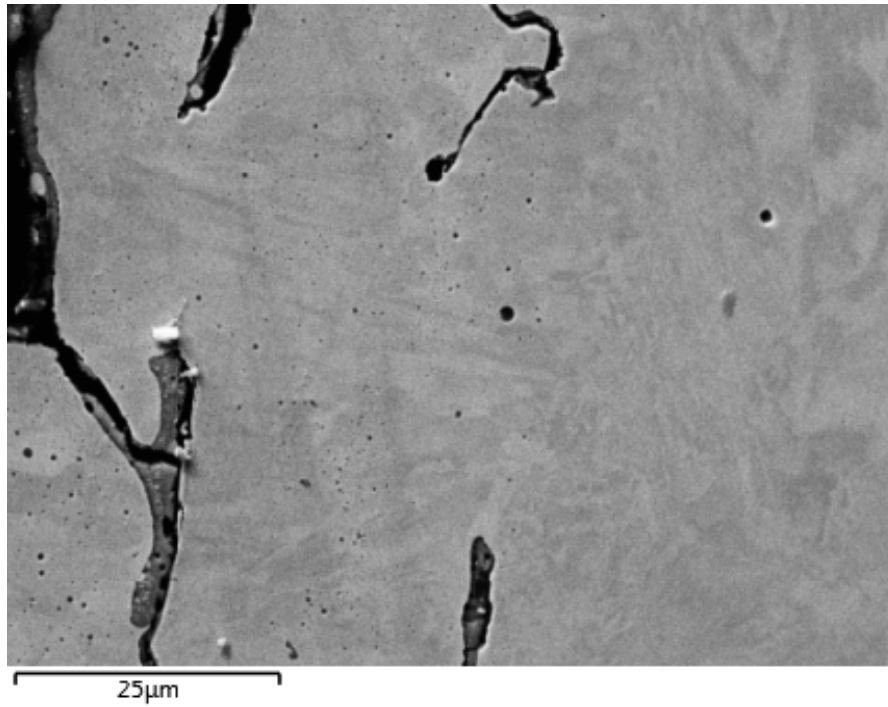
# Line Scans (Ar)



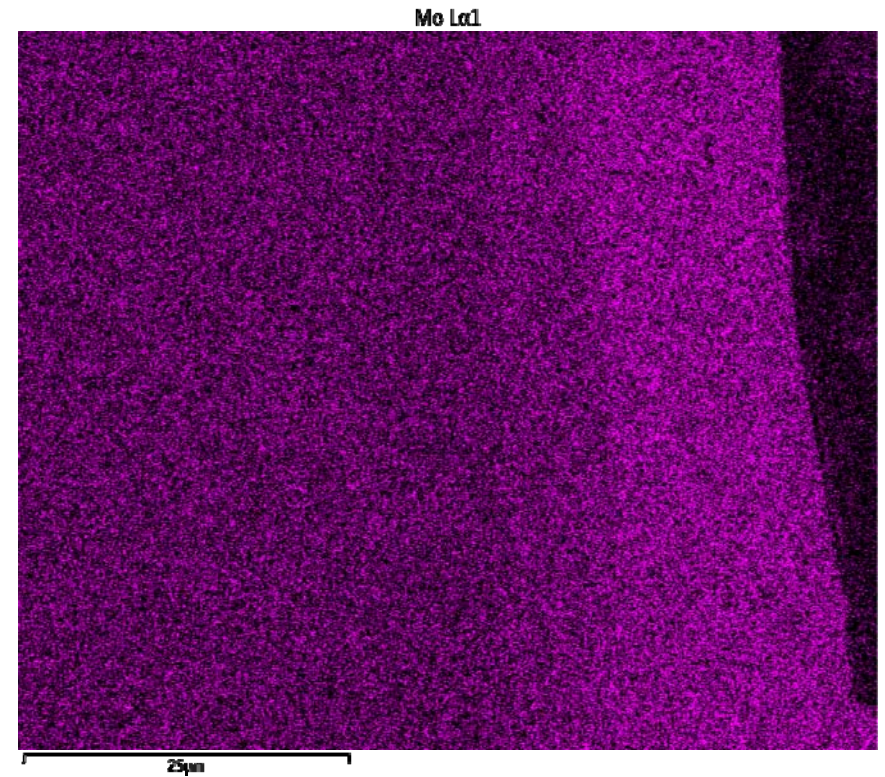
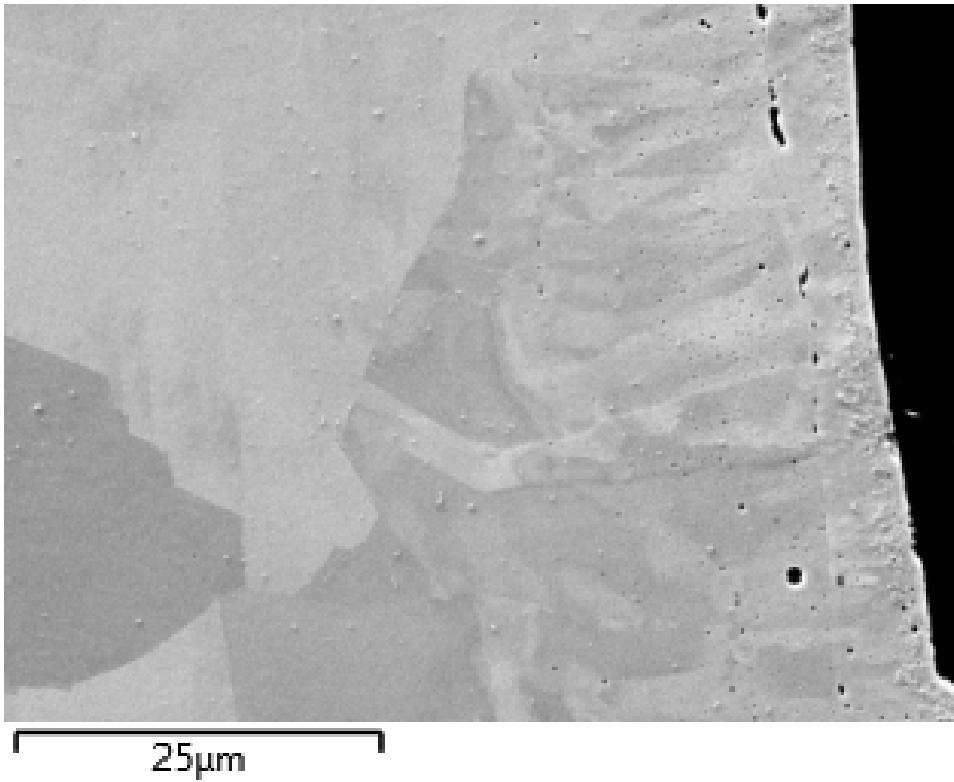
# Line Scans (Ar/H<sub>2</sub>)



# Molybdenum Mapping (Air)

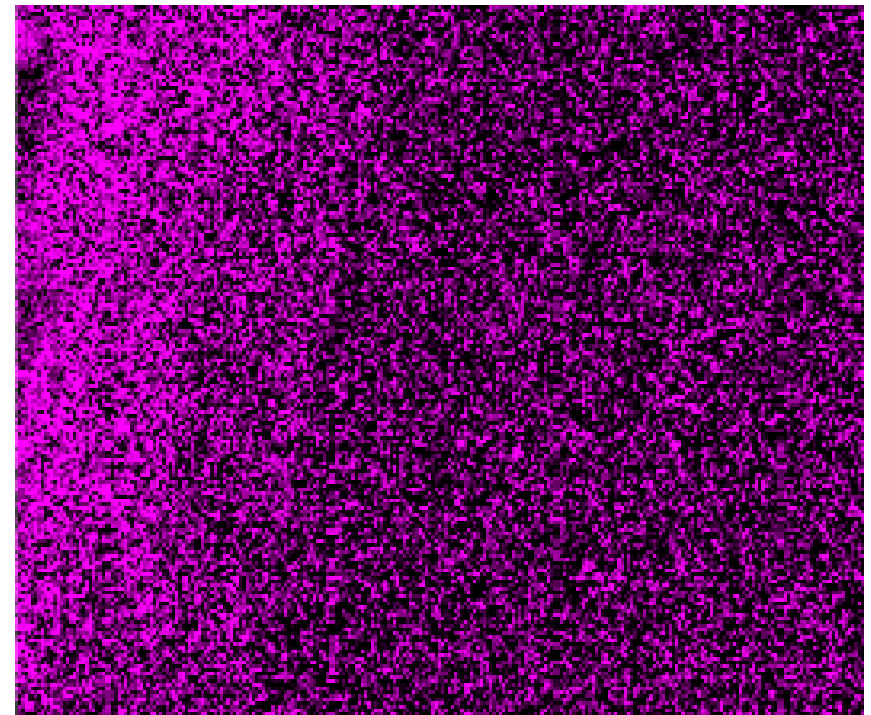
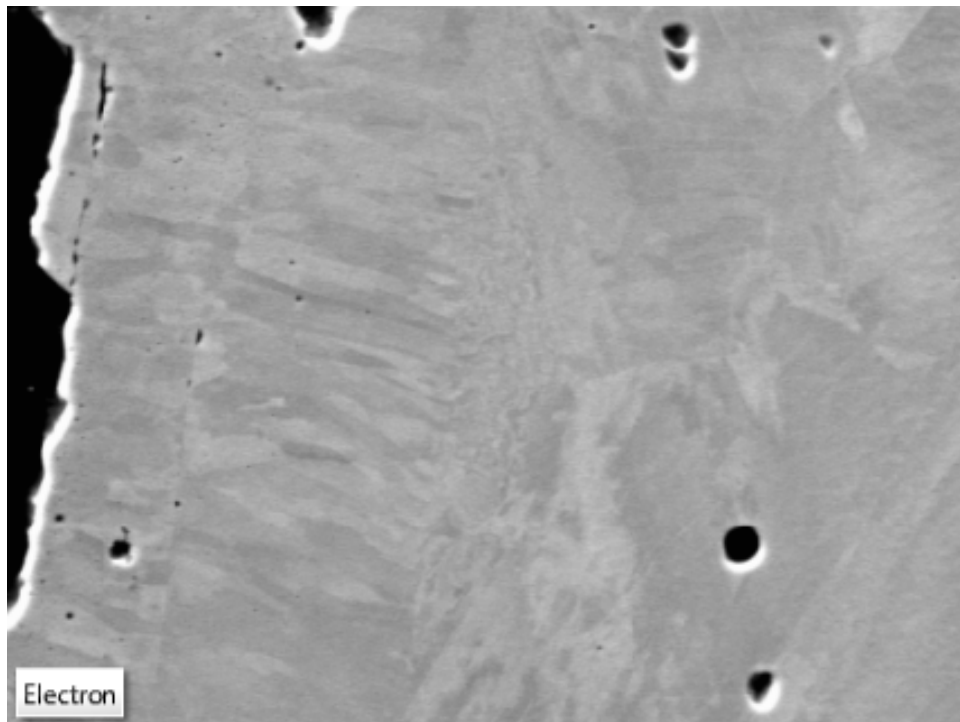


# Molybdenum Mapping (Ar)



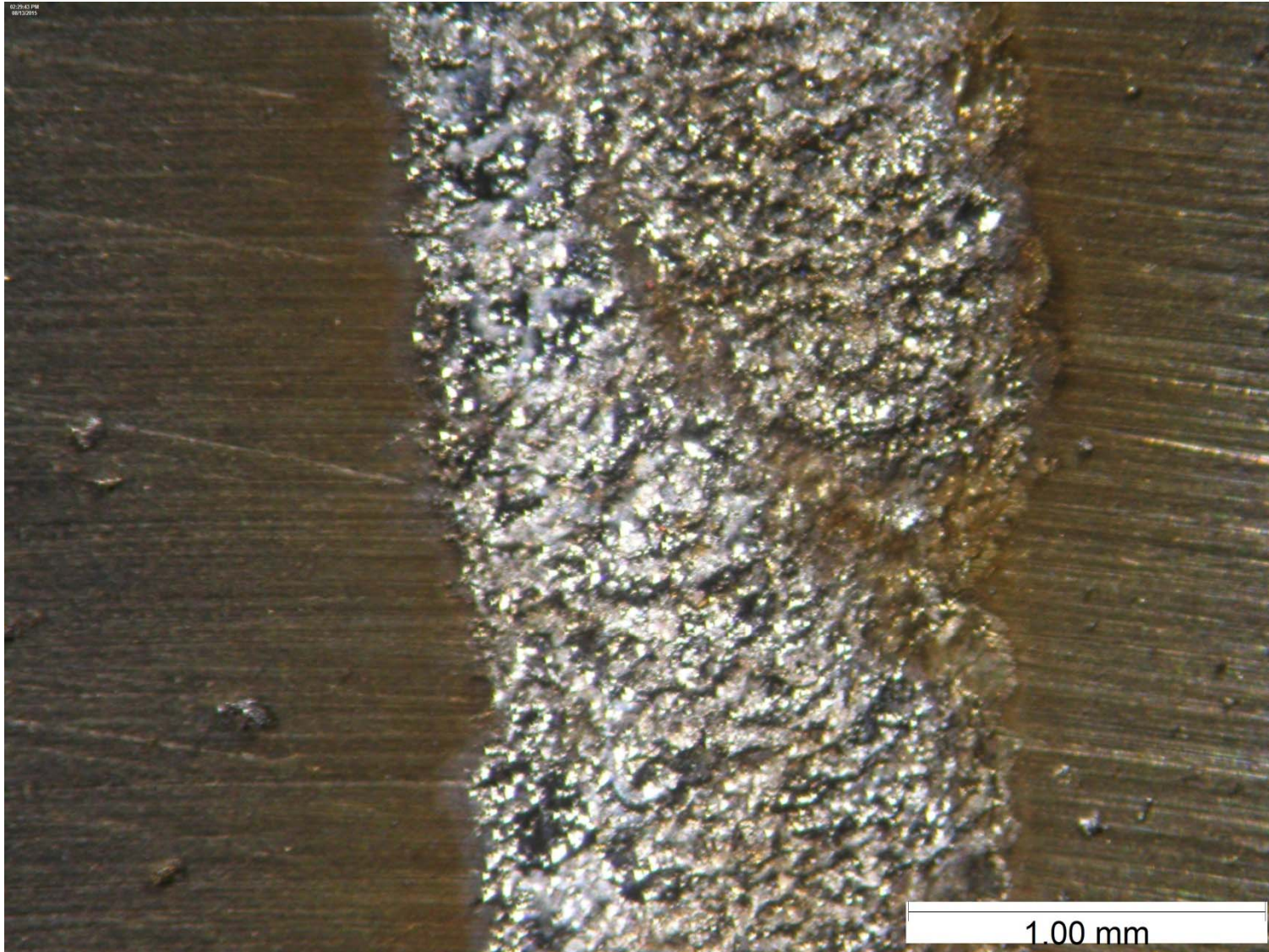
# Molybdenum Mapping (Ar/H<sub>2</sub>)

Mo L series

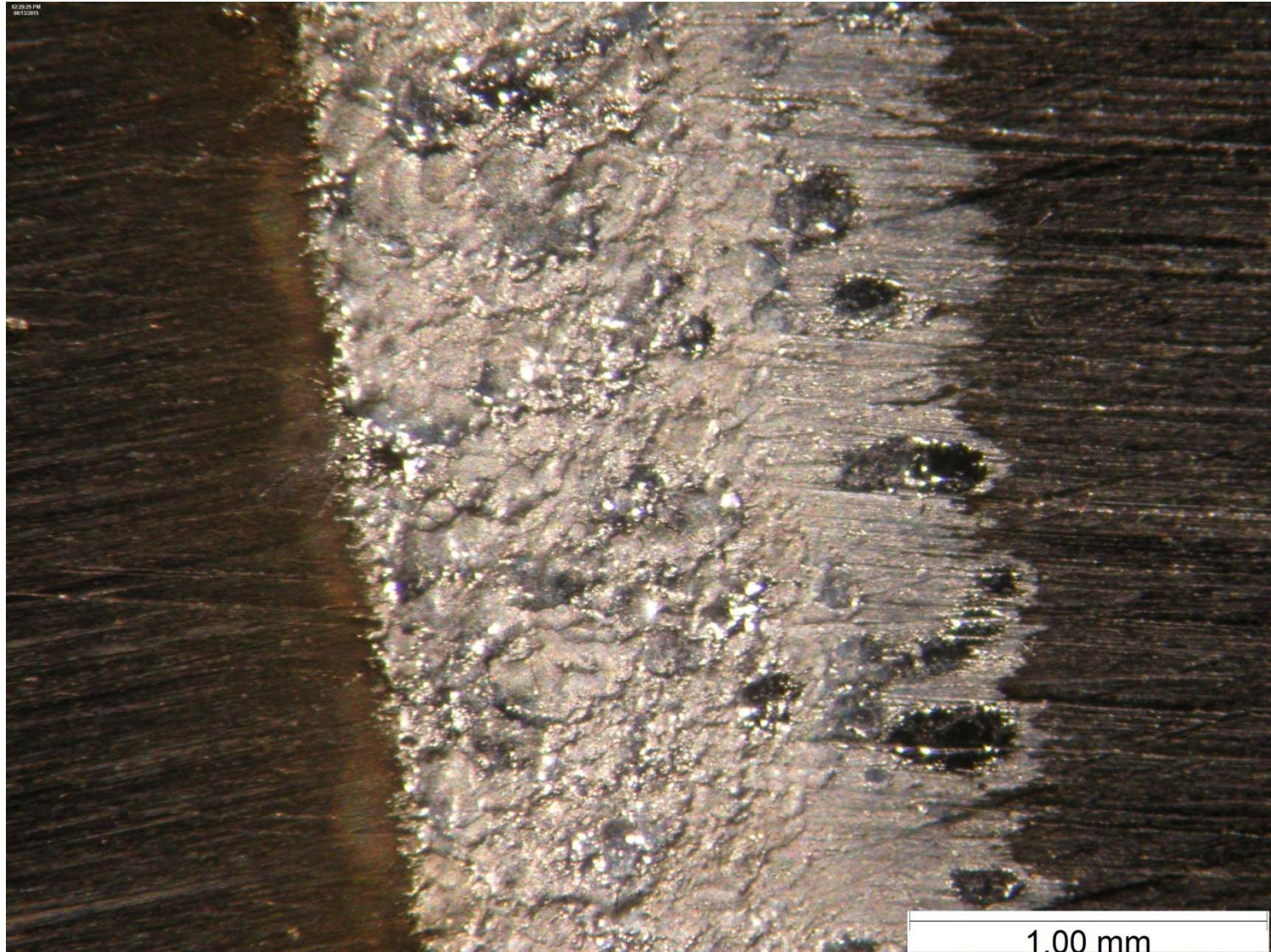




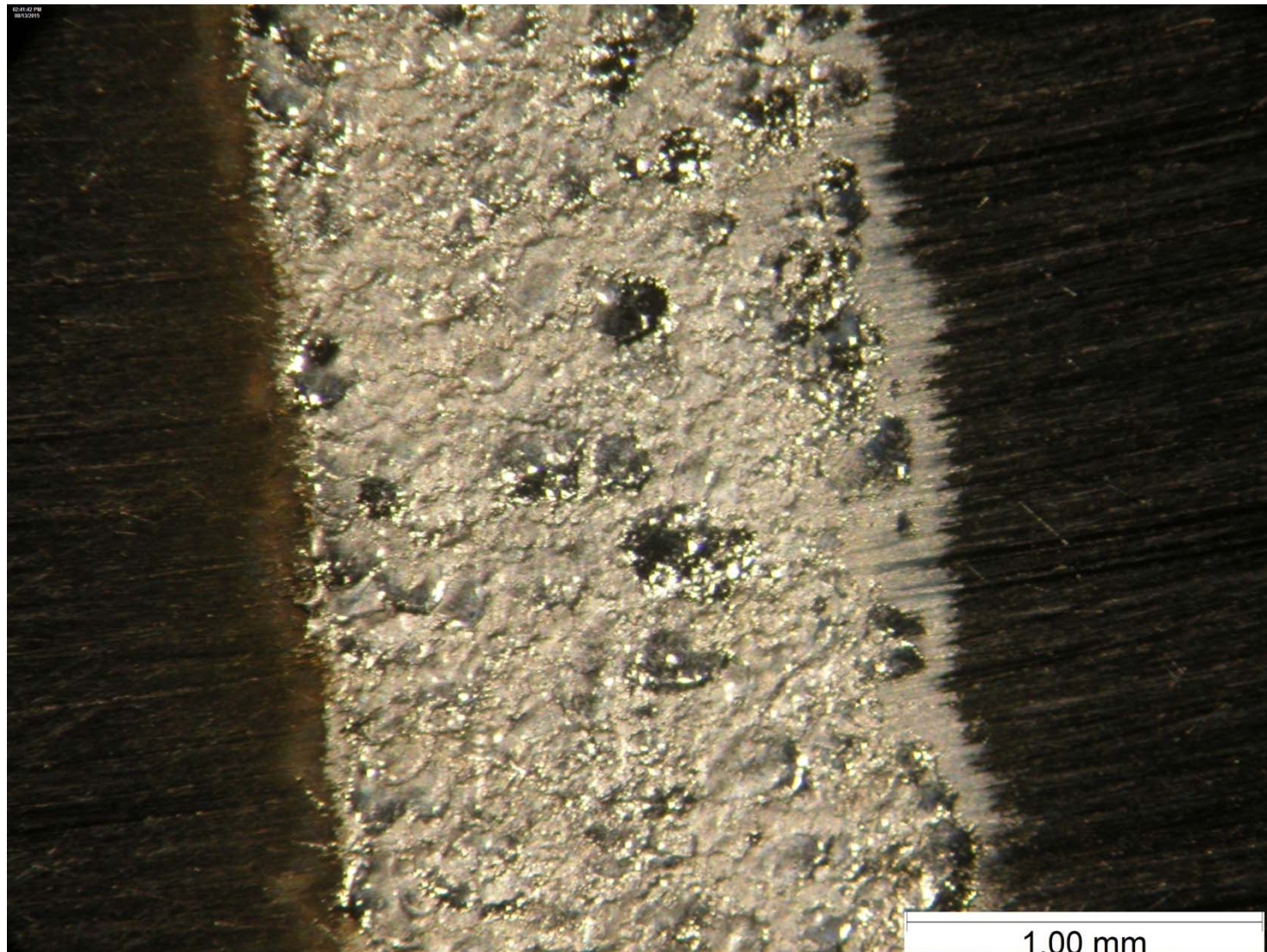
# Oxides Formed in Air



# Oxides Formed in Ar



# Oxides Formed in Ar/H<sub>2</sub>



# Conclusion

- The effects of Hydrogen in shield gas are recordable.
- Hydrogen-Argon combines the oxidation resistance seen in Ar shield gases and, to a lesser degree, the spray transfer seen in air.
- Deposition dilution into the substrate is greater with Ar/H<sub>2</sub> than with pure Ar and is more uniform than dilution in Air.

# Further Studies

- This research is statistically unsupported.
- More Tests
- More characterization of the influence of shield gases on deposition
- Controlling more variables such as forced convection over the electrode and substrate.
- Modeling the deposition process based on an energy balance.

# Thanks To:

- Help in the Lab from Bill Wood, Benjamin Adam and Neneh Switalla
- Jun Jiao, Erik Sanchez and Ellen Bradley
- PSU REU Program

